

Belyakov Vladimir V. Course Schedule

FRIDAY

12:45 — 14:20	☑	LEC	Information and measurement systems in microelectronics	👥 S16-401, S16-402	📍 ДОТ
12:45 — 16:05	☑	SEM	Information and measurement systems in microelectronics	👥 S16-401, S16-402	📍 ДОТ
14:30 — 16:05	☑	LAB	Information and measurement systems in microelectronics	👥 S16-401, S16-402	📍 ДОТ